

**INFORMATION DISCLOSURE
CITATION FORM FOR
PATENT APPLICATION
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(Substitute)**

Docket No. 02W155

Serial No.:

Applicant(s): Kennedy et al.

Filing Date: Herewith

Group:

U.S. PATENT DOCUMENTS

Examiner Initials	Document Number (Number-Kind Code)	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant	Class	Sub-class
WJ	US-6,326,611	12-04-2001	Kennedy et al.	250	239
	US-6,122,919	09-26-2000	Patel et al.	62	51.1
	US-6,077,046	06-20-2000	Kennedy et al.	417	48
	US-6,043,982	03-28-2000	Meissner	361	704
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FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number (Country Code-Number-Kind Code)	Publication Date (MM-DD-YYYY)	Name Of Patentee of Applicant	Translation? Yes/No/n/a
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OTHER DOCUMENTS (Author (Capitalize), Title, Date, Pages, Etc., if known)

"Fluxless High-Vacuum Packaging of MEMS and IR Sensors", SST International, September 2002.

Examiner's Signature:

Viktor Tish

Date Considered:

8/18/05

Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered.

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